

# **31st ASPE Annual Meeting 2016**

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# Technical and Poster Sessions

The technical program of the 31st ASPE Annual Meeting contains over 120 papers on precision engineering state-of-the-art research. Papers that lent themselves to significant verbal interaction have been selected for poster presentation. Authors will present their work during both poster sessions on Tuesday, October 25 from 3:30PM – 5:00PM and on Thursday, October 27 from 3:00PM – 4:00PM.

## Welcome Remarks & Session I

### Precision Design

**Tuesday, October 25, 2016, 8:15AM - 10:00 AM**

Session Chair: Mark A. Stocker (Cranfield Precision, Division of Fives Landis Ltd.) and Mark T. Kosmowski (Electro Scientific Industries, Inc.)

**1. Precision Design\***

Stocker, M. A. (Cranfield Precision, Division of Fives Landis Ltd.);  
Kosmowski, M. T. (Electro Scientific Industries, Inc.)

**2. The Design and Development of a High Precision Machine for Grinding Large Optics**

Fitzpatrick, J. J.; Miller, G. J.; Combrinck, H.; Stocker, M. A.  
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Session Chair: Deepak Ravindra (Micro-Lam Technologies, LLC) and John C. Ziegert (University of North Carolina - Charlotte) and Bradley H. Jared, Sandia National Laboratories

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Ravindra D. (Micro-LAM Technologies, LLC); Ziegert, J. C.  
(University of North Carolina -Charlotte);  
Cheung, C.-F. (The Hong Kong Polytechnic University); Marsh, E. R.  
(The Pennsylvania State University); Jared, B. H. (Sandia National Laboratories);  
Roblee J. W.; Hashimoto, T.; (AMETEK - Precitech, Inc.)

**\*No Abstract Available**

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